

Supplementary Information

Highly Efficient Inorganic-Organic Heterojunction Solar Cells Based on SnS-sensitized Spherical TiO₂ Electrodes

Wei Guo, Yihua Shen, Mingxing Wu and Tingli Ma*

State Key Laboratory of Fine Chemicals, School of Chemical Engineering, Environmental and Biological Science and Technology, Dalian University of Technology, Dalian, 116024, P. R. China
*E-mail: tinglima@dlut.edu.cn

Experimental Details

10 Synthesis of spherical TiO₂ powders and films

Preparation of spherical TiO₂ was performed in the presence of hexadecylamine (HDA), as structure-directing agent, via a sol-gel method, followed by a solvothermal treatment. The solution composition of HDA: H₂O: KCl: ethanol: TTIP (molar ratio) was varied, in the range of 0.33:3:5.5×10⁻³:236.5:1.0. The detailed process is described in the reference.^[1]

Synthesis of nanocrystalline TiO₂ powders

15 Nanocrystalline TiO₂ particles were synthesized by hydrothermal methods.^[2] Briefly, titanium alkoxide solution (TTIP (titanium iso-propoxide): acetic acid=1:1 (molar ratio)) was poured into deionized water under vigorous stirring at room temperature. After peptization, the resultant mixture was treated in a titanium autoclave at 250 °C for 12 h. Finally, the resultant colloidal solution was concentrated and centrifuged to produce a white precipitate of TiO₂ particle.

Preparation of ordered mesoporous TiO₂ films

20 Well-ordered mesoporous TiO₂ films were prepared via a supramolecular-templated route and a subsequent layer-by-layer deposition.^[3] Triblock copolymer Pluronic F127 was used as structure-directing agent. The precursor solution was composed of TTIP: AcAc: HCl: H₂O/ethanol: F127. Then, the solution was deposited on FTO glass by spin coating. The films were sintered to remove organic solvent and to improve the nanocrystallinity of the mesoporous TiO₂. The thickness of the well ordered TiO₂ films was *ca.* 5 μm.

Fabrication of TiO₂ electrodes

25 To prepare the electrodes, parts of the conductive layer on the FTO glass were first etched using zinc powder and hydrochloric acid. Then, the FTO was washed and sonicated in ethanol and acetone. A dense TiO₂ layer was spin coated on the conductive layer using TiO₂ organic sol and sintered at 450 °C for 2 h.^[4] TiO₂ powder were dispersed in the solution of terpineol and ethyl cellulose to form viscous paste. Then, the paste was coated on the pre-patterned FTO glass using a doctor-blade method. The films were sintered at 500 °C for 30 min in air. Next, the films were soaked in 40 mM TiCl₄ at 70 °C for 30 min, and then sintered again at 500 °C for 30 min in air. The thickness of the films was controlled to be *ca.* 8 μm.

30 SnS deposition

SnS-sensitized TiO₂ films were prepared by a modified chemical bath deposition (CBD).^[5] Considering the wetting properties of TiO₂ films, we adjusted the solvent of the CBD solution, from pure water to a mixed solution of ethanol and deionized water. The SnS CBD solution was composed of 1.13g SnCl₂ dissolved in 5 mL acetone, 8 mL of 98% triethanolamine, 8 mL thioacetamide, and 6 mL 25%-28% ammonia solution. The total volume of the solution was adjusted to 100 mL using a mixed solution of ethanol and deionized water (v/v, 2:8). For the SnS deposition, the TiO₂ films were placed 35 in the CBD solution at 75 °C for varying times.

Solar cell fabrication

Poly(3-hexylthiophene) (P3HT, Sigma Aldrich, 15 mg/mL in chlorobenzene) was spin coated on TiO₂-SnS films at 2500 rpm for 60 s and dried on a hot plate at 110 °C for 10 min. Then, a poly (3-4-ethylenedioxythiophene) doped with poly (4-stylenesulfonate) (PEDOT: PSS, Sigma Aldrich) was spin coated twice on TiO₂-SnS-P3HT films at 2500 rpm for 60 s, and then dried at 110 °C for 10 min. Silver paste was coated on the top of a TiO₂-SnS-P3HT- 40 PEDOT: PSS film using a doctor-blade method and dried at 100 °C for 10 min. To completely remove the solvent, the devices were annealed at 90 °C for 2 h in a vacuum oven. The active area of the devices was 0.12 cm². A mask made of black tape, with an area of 0.04 cm², was used to define the illumination area of the devices.

Characterization.

The phase compositions of TiO₂ and SnS were determined using X-ray diffraction analysis (XRD, D/MAX-2400) with Cu Kα radiation (γ=0.154 nm). 45 Microstructures of spherical TiO₂ films were studied using field-emission scanning electron microscopy (FE-SEM S-4800, Hitachi). An automatic adsorption apparatus (Belsorp 18-plus) was used to analyze the surface areas of TiO₂ films by Brunauer-Emmett-Teller (BET) method. The UV-Vis reflection spectra were measured using a spectrophotometer (JASCO V-570). Current-voltage curves of HSCs were obtained at ambient conditions by applying an external bias to the cells and measuring the generated photocurrent under white light irradiation using a digital source meter (Keithley 2601) and a solar simulator (100 mW/cm², PEC-L15). Photon flux was determined using a power meter (Nova, Ophir Opttronics Ltd.) and a calibration cell (BS- 50 520, s/n 019, Bunkoh-Keiki Co., Ltd.). The electron lifetime (τ) and charge extraction measurement were performed using the SLIM-PCV (PSL-100, EKO) with stepped laser beam. The Fermi level potential of SnS/TiO₂ and TiO₂ films were analyzed using an impedance spectrum analyzer (Zahner IM6e) along with the Mott-Schottky equation,^[6] i.e.

$$\frac{1}{C^2} = \left(\frac{2}{e\epsilon_0\epsilon N_D} \right) \left(E - E_F - \frac{kT}{e} \right)$$

where *C* represents the capacitance of the space charge region, ε₀ the vacuum permittivity, ε the dielectric constant of the TiO₂ layer, *e* the electron charge, 55 *E* the applied potential, *E_F* the Fermi level potential, *k* the Boltzmann constant, *T* the absolute temperature, and *N_D* the donor density. The temperature term is generally small and can be neglected. In this work, measurements were performed by applying a sinusoidal potential perturbation with a small

amplitude (10 mV), superimposed on a fixed dc potential, varying within appropriate potential windows from -0.6 to 0 V (vs. Ag/AgCl) in PBS buffer solution (10 mM Na₂HPO₄/KH₂PO₄; 2 mM K₃PO₄; 137 mM NaCl; 2.7 mM KCl, pH 7.4-7.6; Shanghai Sangon Biological Engineering Technology & Service Co., Ltd.). The TiO₂ films used for this analysis had a film thickness of *ca.* 6 μm.

References

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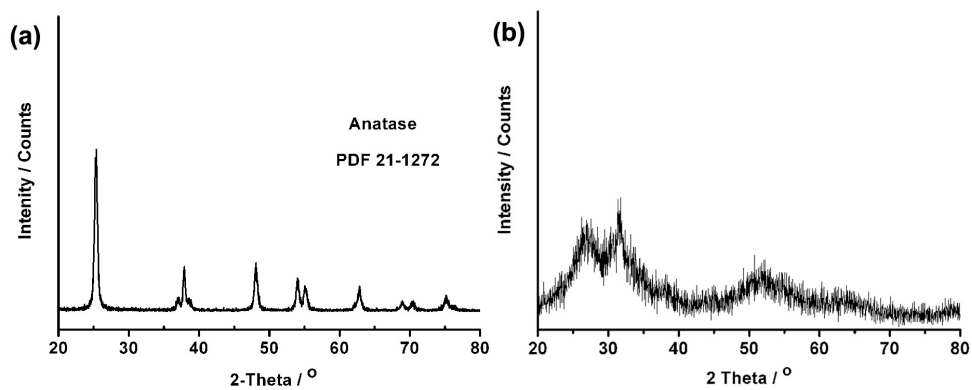


Figure S1. XRD patterns of TiO₂ powder (a) and SnS (b) deposited in chemical bath at 80 °C for 3 h.

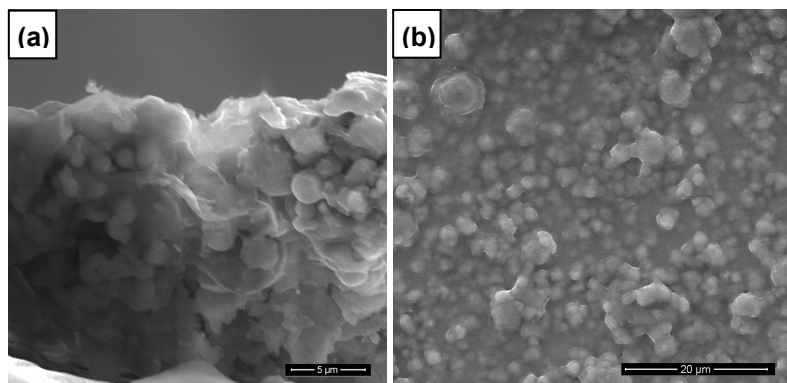


Figure S2. SEM images of the cross section of SnS-HSCs (a) and plane section of TiO₂-SnS-P3HT (b).

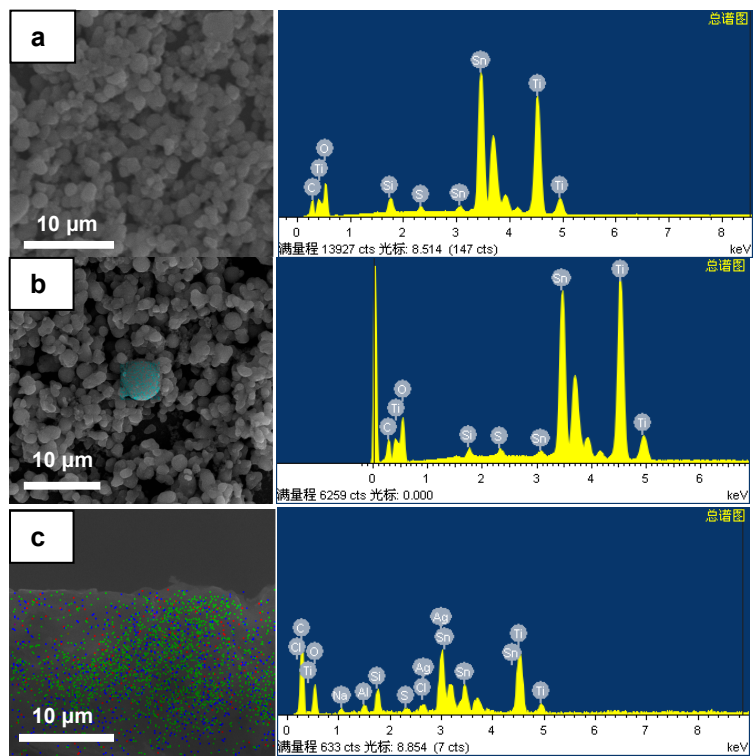


Figure S3. EDX spectra. (a) SnS-TiO₂ film; (b) SnS-sensitized a single TiO₂ sphere; (c) Cross-section of TiO₂-SnS-P3HT-Ag HSCs, Ti (red), Sn (blue), S (green).

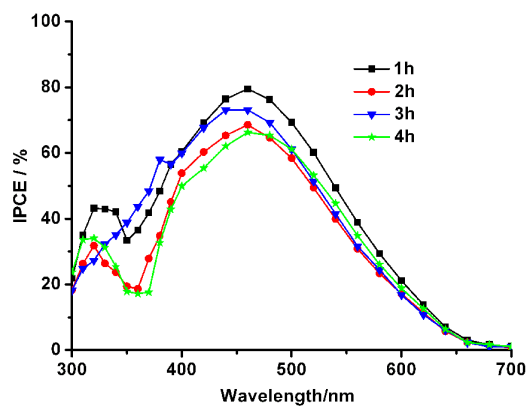


Figure S4. IPCE spectra of SnS-HSCs varying with CBD time.

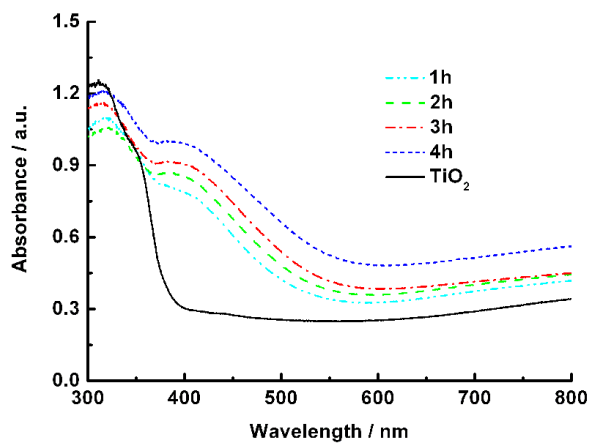


Figure S5. UV-Vis absorption spectra of SnS-TiO₂ films with varying SnS CBD time.

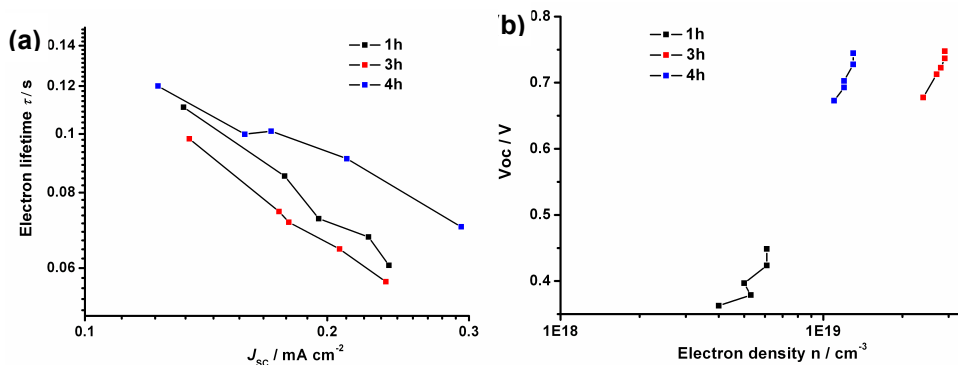


Figure S6. (a) J_{sc} dependent τ ; (b) electron density n dependent V_{oc} of SnS-HSCs with varying SnS CBD time.

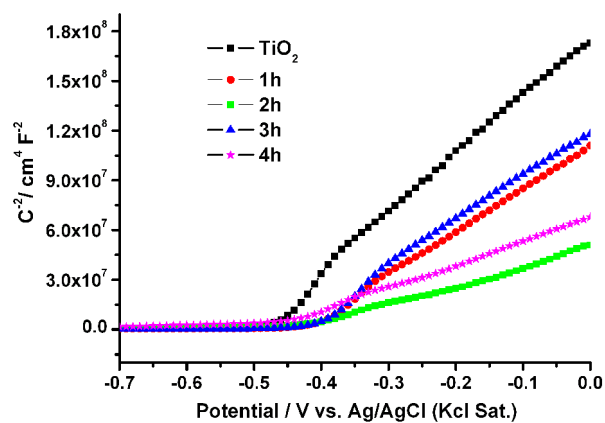


Figure S7. Mott-Schottky curves of TiO_2 and TiO_2 -SnS films. The thickness of TiO_2 films were *ca.* 6 μm .

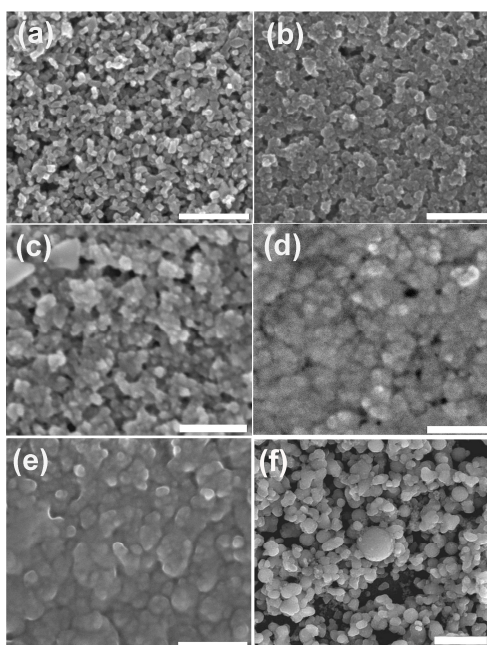


Figure S8. SEM images of SnS-sensitized nc- TiO_2 films varying with CBD time. (a) 0h; (b) 1h; (c) 2h; (d) 3h; (e) 4h, scale bar 200 nm; (f) SnS-sensitized spherical TiO_2 films with the CBD time 3h, scale bar 10 μm .